



03500.015514.

#7 IDS *w/fee*  
PATENT APPLICATION

*DSmalls-logger*

*2/4/03*

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

TADAYASU MEGURO ET AL.

Application No.: 09/845,286

Filed: May 1, 2001

For: ELECTRON SOURCE FORMING )  
SUBSTRATE, AND ELECTRON )  
SOURCE AND IMAGE DISPLAY )  
APPARATUS USING THE SAME )

Examiner: T. Phan

Group Art Unit: 2841

January 28, 2003

RECEIVED  
JAN 31 2003  
TECHNOLOGY CENTER 2800

Commissioner for Patents  
Washington, D.C. 20231

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the following co-pending U.S. Application, a copy of which is enclosed:

01/30/2003 HQEBREM1 00000037 09845286

01 FEB 2003

180.00 DP

APPLICATION NO.

09/440,535

FILING DATE

11/16/99

GROUP ART UNIT

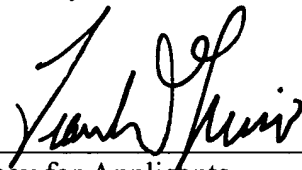
2879

It is respectfully requested that the above information be considered by the Examiner.

Enclosed is a check in the amount of \$180.00 for the fee required to have this Information Disclosure Statement considered. Please charge any deficiency in this fee, or credit any payment, to Deposit Account 06-1205.

Applicants' undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our address given below.

Respectfully submitted,



Attorney for Applicants

Registration No.

42,476

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